

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: : Date: April 26, 2001  
Zhiyi Yu et al. :  
Docket No: JG00143 :  
Filed: Concurrently herewith :

For: STRUCTURE AND METHOD FOR FABRICATING SEMICONDUCTOR  
STRUCTURES AND DEVICES USING BINARY METAL OXIDE LAYERS

U.S. PTO  
09/842734  
04/26/01

88  
4-29-02

DISCLOSURE STATEMENT UNDER 37 C.F.R. 1.56

Honorable Assistant Commissioner for Patents  
Washington, D.C. 20231

SIR:

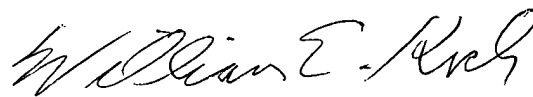
It is respectfully requested that the art listed on FORM PTO-1449 be considered in the examination of the subject application and made of record therein. A copy of the listed art is enclosed herewith.

No representation is made or intended that the listed art enclosed herewith is material to patentability of the subject patent application.

No representation is made or intended that a search has been made or that no better art than that listed is available.

Respectfully submitted,

Zhiyi Yu et al.



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